

Simulation of Photodetectors and Radiation Effects in Synopsys TCAD

SIMDET 2021

Synopsys TCAD Team

Ric Borges

29 November 2021

Outline

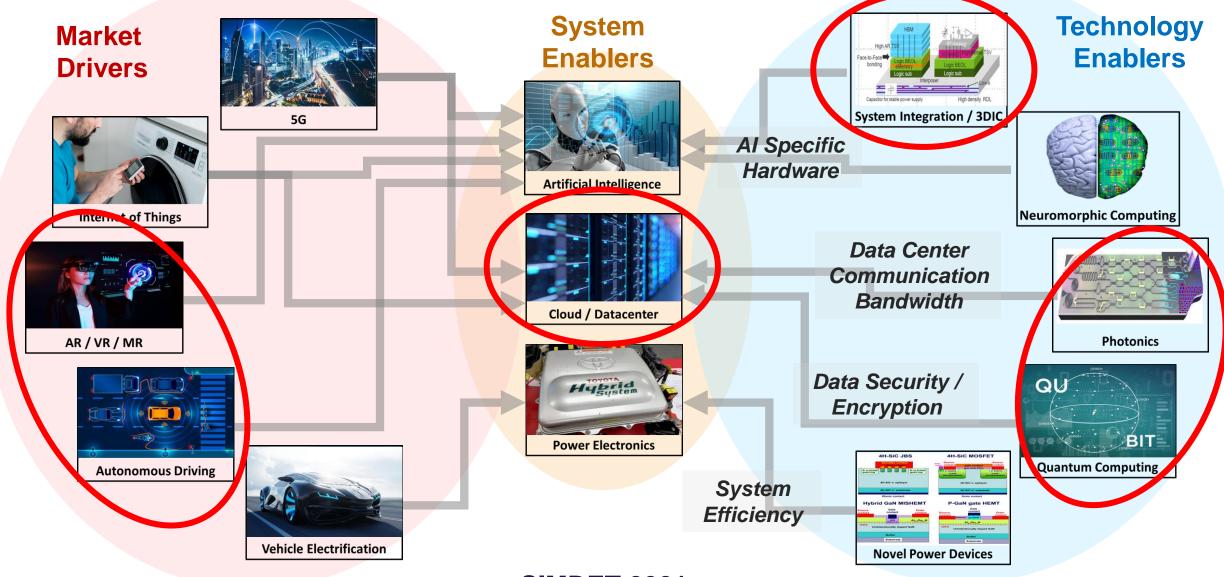
- Semiconductor Industry Trends
- Photodetector Simulation
- Particle / Radiation Detection

Semiconductor Industry Trends



Transformational Applications Continue to Motivate and Drive

Semiconductor Industry Growth



Optical Sensors and Detectors Are Pervasive in Consumer Applications ...



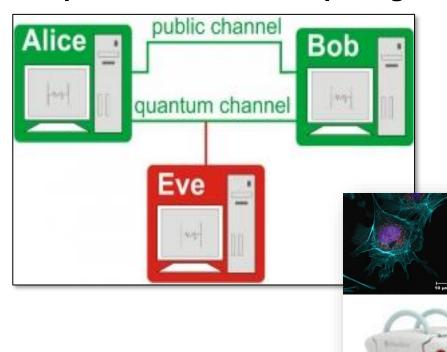






... And Are System Enablers in Industrial and Scientific Applications

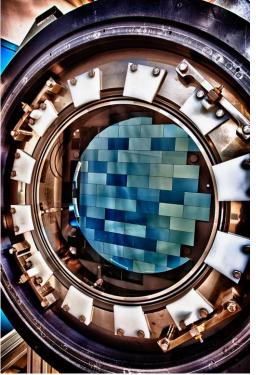
Quantum Communication / Optical Quantum Computing



Remote Sensing / Ranging



Particle Physics



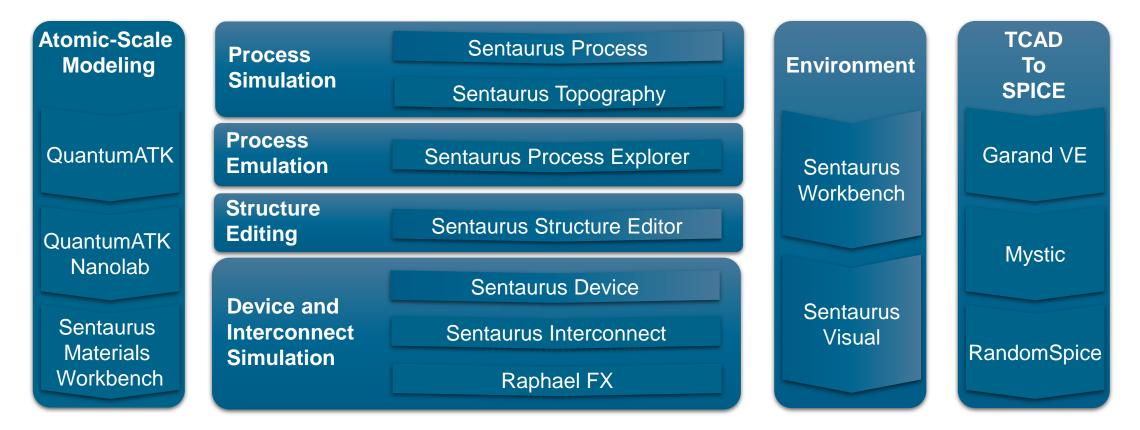
Medical Imaging

Photodetector Simulation

- Optical Solvers in Sentaurus
- CMOS Image Sensors
- Single Photon-Avalanche Diodes
- Superconducting Nanowire Single-Photon Detectors



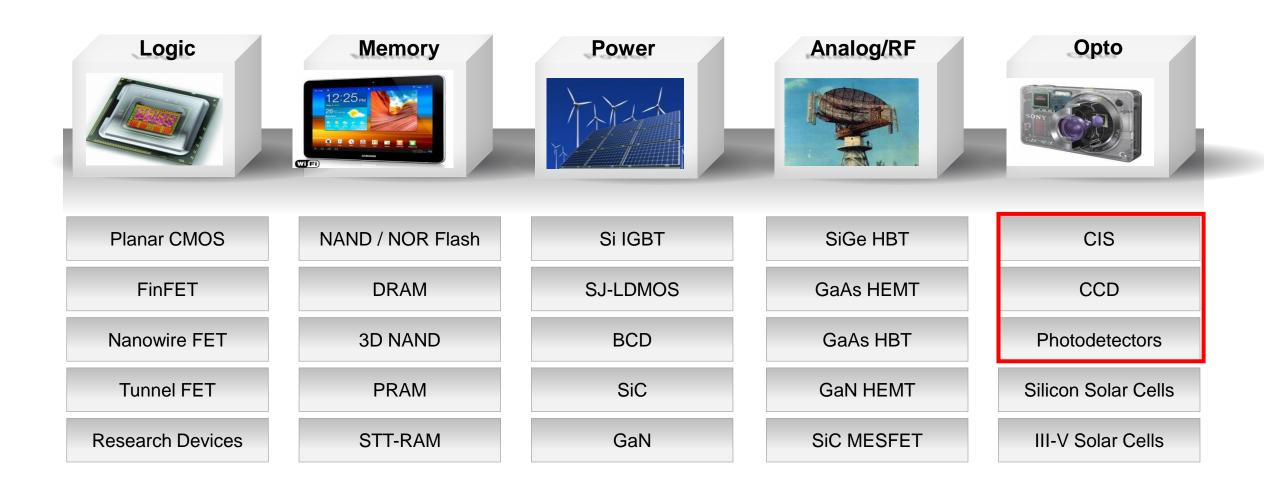
Synopsys TCAD Product Family is the Industry Leader



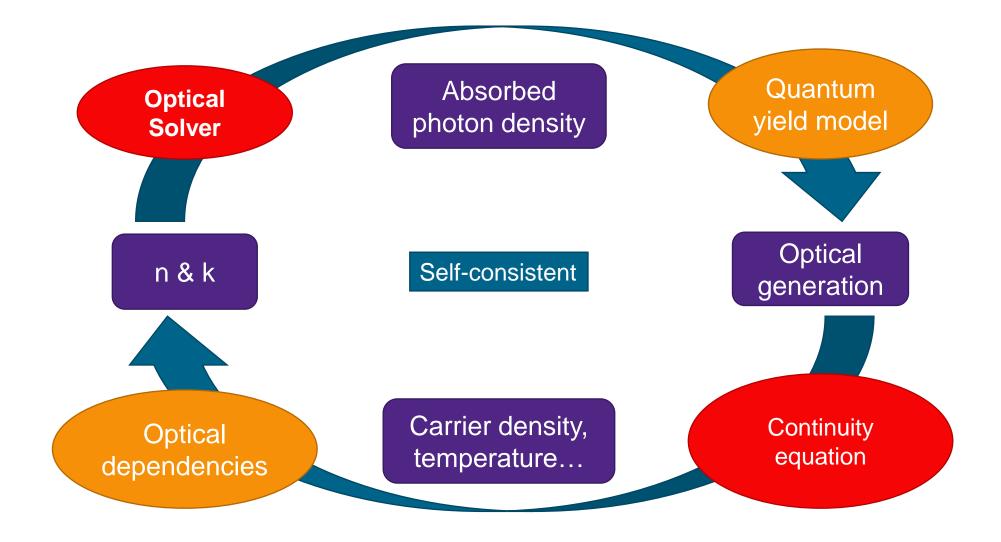
- Production-proven 3D simulation technology
- Integrated simulation flows: atomic-scale, TCAD, SPICE model extraction
- Most accurate results through atomic-scale modeling and calibrated TCAD models

Sentaurus Covers All Major Semiconductor Segments

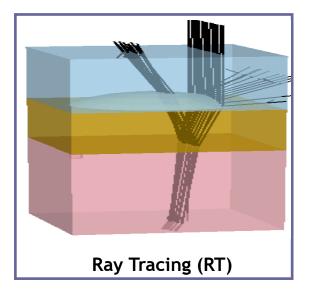
Solutions For Advanced Logic, Memory, Power, Analog/RF, Opto-Electronics

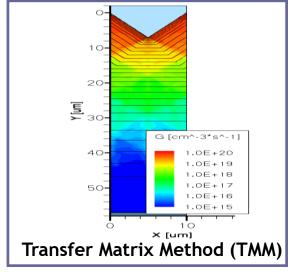


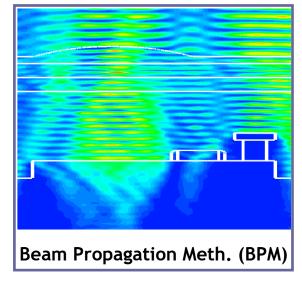
General Optoelectronics Simulation Flow

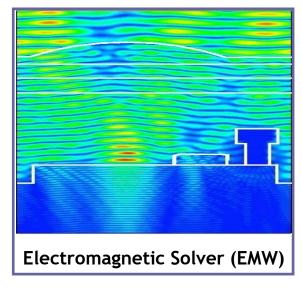


Optical Models in Sentaurus Device





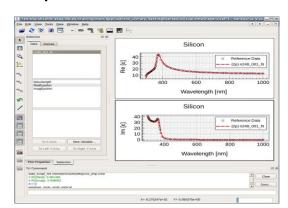


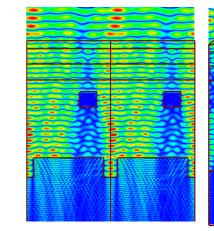


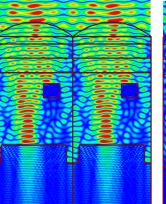
Sentaurus Device EMW: Highly Accurate Optical Solver

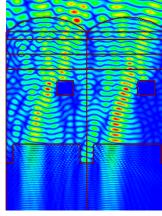
• Simulates the propagation of electromagnetic waves via full-wave, time-domain solution (FDTD) of Maxwell's equations

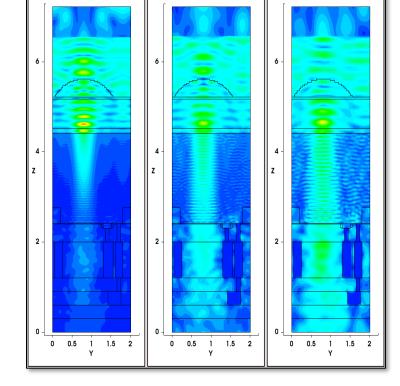
- Simulates refraction, reflection, diffraction / interference and absorption
- Automatic Reflection, Transmission, Absorption (RTA) extraction
- Supports all major boundary conditions
 - Perfect Electric Conductor (PEC), Perfect Magnetic Conductor (PMC)
 - Periodic, periodic oblique
 - Absorbing: Mur, Higdon, Convolutional Perfectly Matched Layer (CPML)
- Multiple excitation sources: plane wave, Gaussian beam, CODE V
- Dispersive media models











550 nm

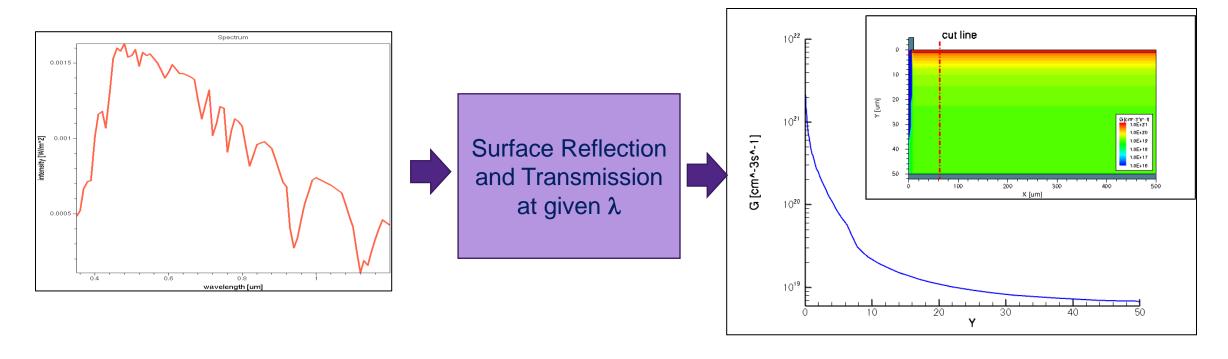
650 nm

475 nm

SYNOPSYS°

Optical Generation is Calculated as a Function of Depth and λ

- Light absorption in semiconductor regions leads to optical generation
- The structure may contain reflectors or other structures used to increase collection efficiency



Device Simulation Applied to Optoelectronic Devices

System of semiconductor device equations:

• In majority of cases, drift-diffusion is sufficient for treating current transport in optoelectronic devices:

$$\mathbf{J}_{\mathbf{n}} = -nq\mu_{\mathbf{n}} \nabla \Phi_{\mathbf{n}} \qquad \mathbf{J}_{\mathbf{p}} = -pq\mu_{\mathbf{p}} \nabla \Phi_{\mathbf{p}}$$

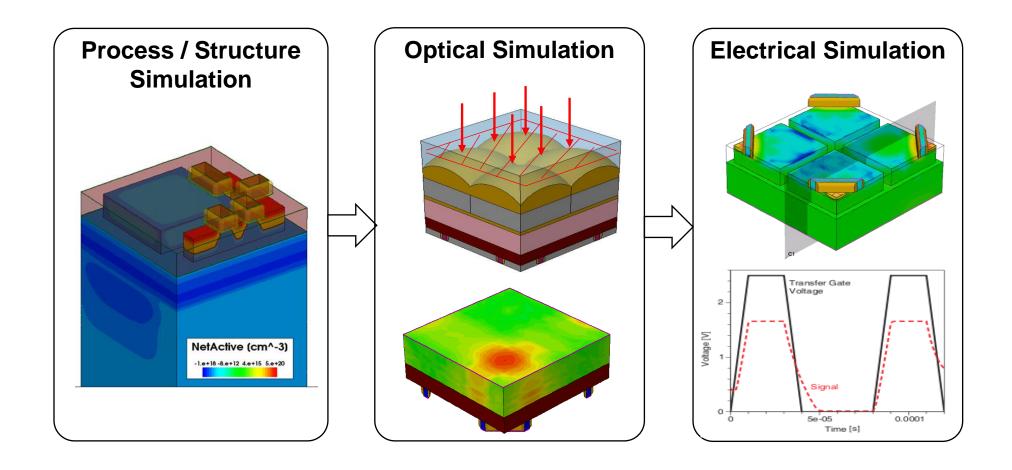
- Solution modes:
 - Quasi-static (I-V curves, EQE vs λ, etc)
 - Transient (light pulses, current/voltage pulses)
 - Small-Signal AC (responsivity, ...)

Photodetector Simulation

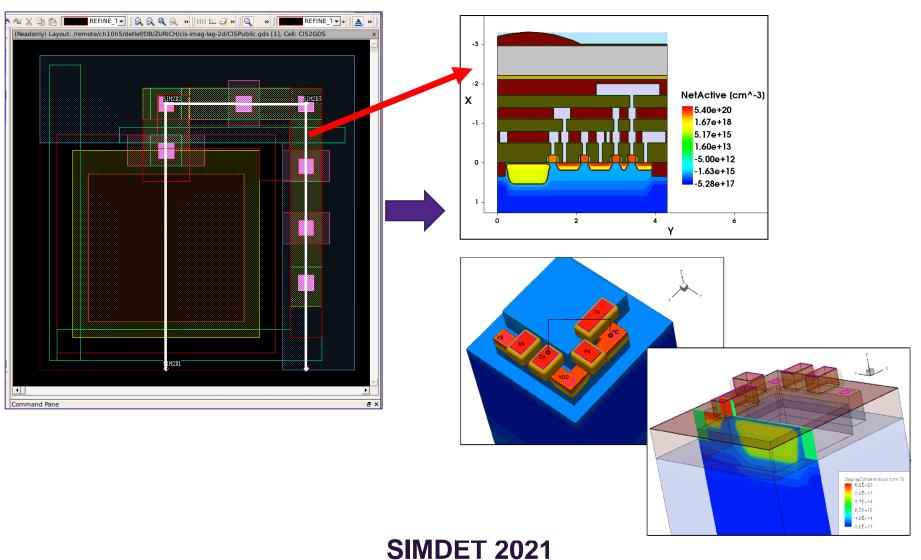
- Optical Solvers in Sentaurus
- CMOS Image Sensors
- Single-Photon Avalanche Photodetectors
- Superconducting Nanowire Single-Photon Detectors

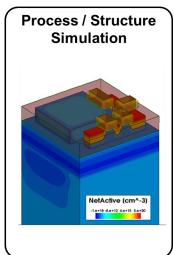


Sentaurus Offers a Fully Integrated TCAD Solution for CIS

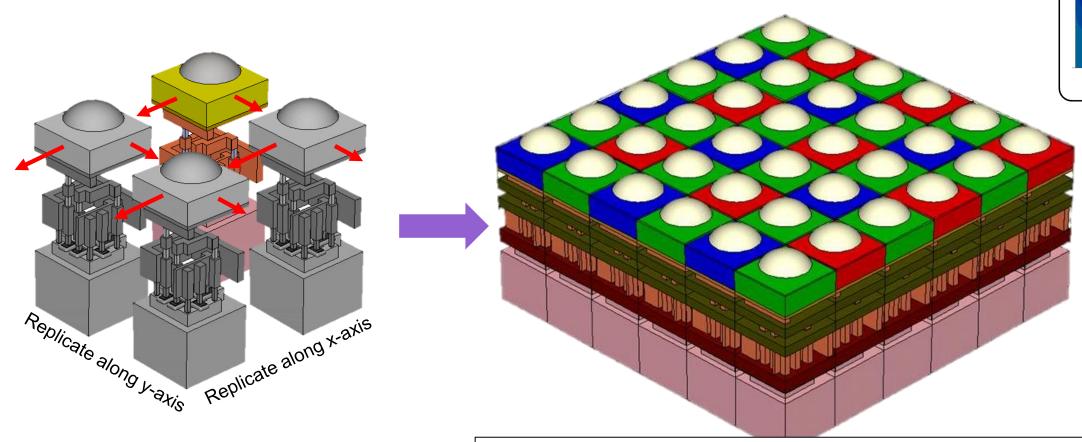


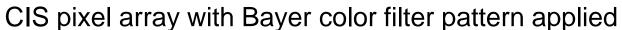
Sentaurus Provides a Capability to Generate CIS Structures from Mask Information





Sentaurus Offers Flexible Ways to Replicate CIS Structures to Construct Pixel Arrays

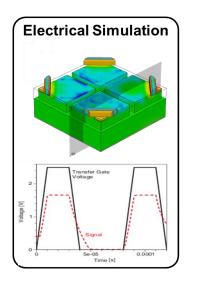


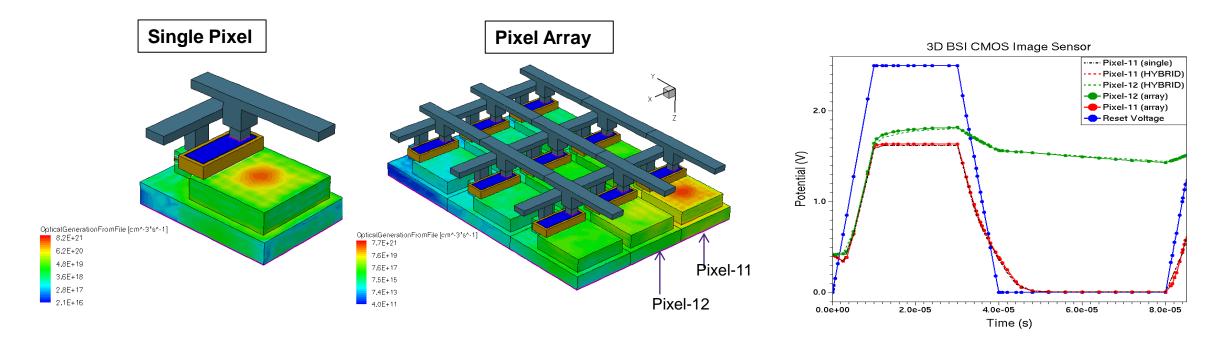


Process / Structure Simulation

Device Simulation Enables Analysis and Mitigation of Crosstalk

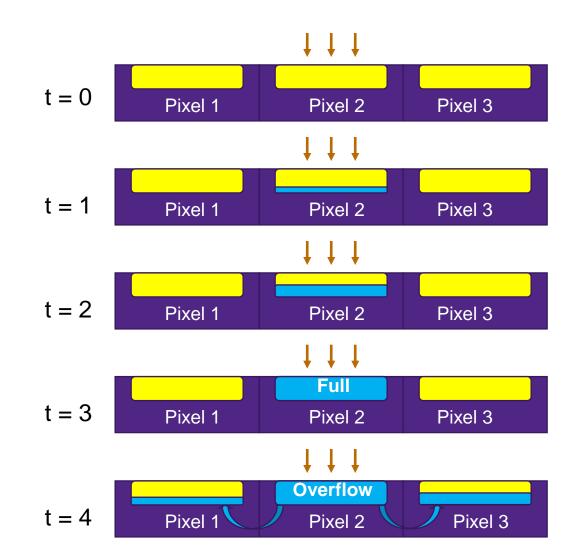
- Electrical simulation is performed on target pixel (11) and adjacent pixel (12) to investigate optical cross talk
- Change to potential in pixel 12 after reset indicates crosstalk

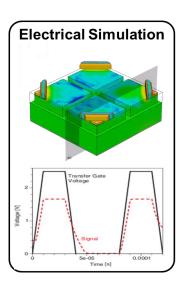




Analysis of Blooming Effect

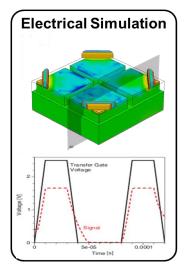
- Light source overloads capacity of pixel; number of generated electrons exceeds capacity of the doping well
- "Spillover" of electrons from illuminated pixel into the neighboring pixels
- Typically a problem with CCDs
- CMOS image sensors can also be affected depending on layout of pixels





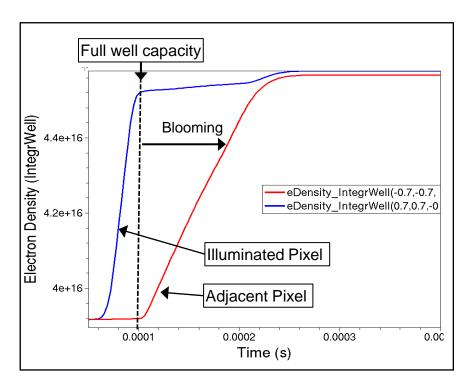
Electrical Simulation Computes the Time Need to Reach Full Well Capacity to Prevent Blooming

- In this example, at 0.105 μs the well reaches full capacity
 - Before this time, only optical crosstalk contributes electrons to adjacent pixels
 - After this time, the electron concentration in adjacent pixels is from "spillover"



Sentaurus Device syntax for capturing integrated electron density over specified region of the CMOS image sensor structure

```
CurrentPlot {
   Potential ( (0.7, 0.7, -0.7))
   eDensity (
       Integrate(DopingWell (0.7 0.7 -0.7))
       Average(DopingWell (0.7 0.7 -0.7))
   )
   OpticalGeneration ( (0.7, 0.7, -0.7)
       Integrate(DopingWell (0.7 0.7 -0.7))
       Average(DopingWell (0.7 0.7 -0.7)))
       Average(DopingWell (0.7 0.7 -0.7)))
    )
}
```



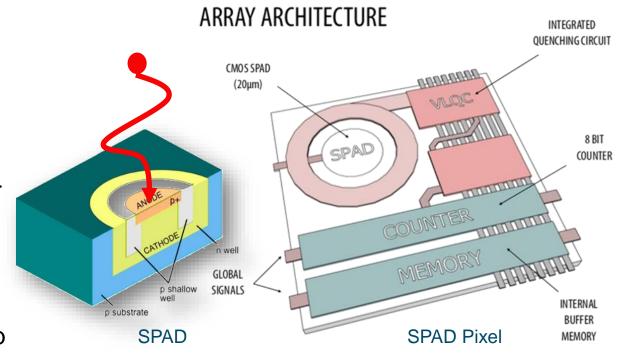
Photodetector Simulation

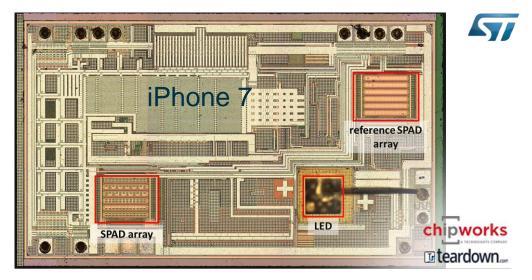
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Single Photon Avalanche Diodes

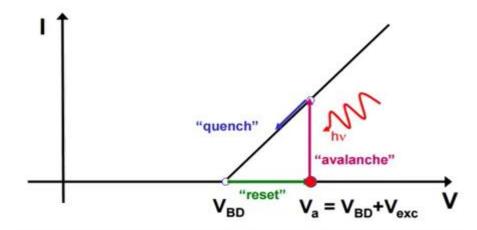
- Device capable of detecting a single photon
 - pn junction biased such that photoexcited carrier rapidly triggers avalanche breakdown
 - Operates as photon counter or Time Of Flight
 - Timing accuracy ~ 30 ps 100 ps
 - Variation due to stochastic transport and build up
 - More sensitive than Avalanche Photo Diodes (APDs)
- Standard CMOS fabrication
 - Sensor integrated with circuitry and logic
 - Combined to form SPAD arrays
- Silicon and III-V architectures
 - Sensitive to different wavelengths

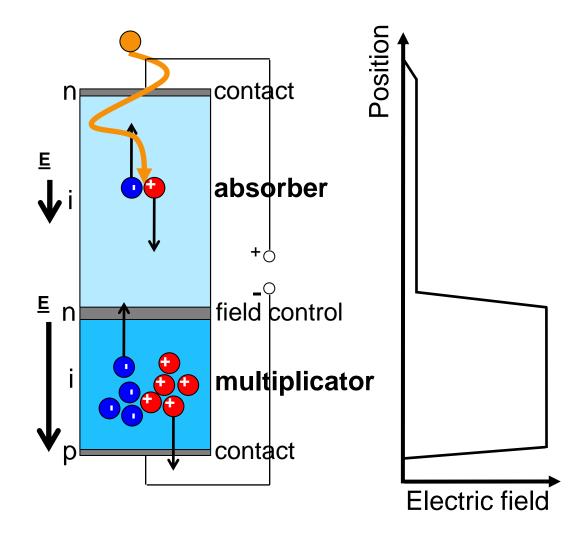




How Do SPADs Operate?

- Bias device at a voltage higher than the breakdown voltage, ie, V_a > V_{BD}
- 2. Single photon creates a detectable current (avalanche)
- 3. Device voltage is reduced below V_{BD} to lower avalanche current (quenching)
- 4. Device voltage is restored back to V_a (reset)
- 5. Device is ready to detect another photon





Synopsys TCAD SPAD Modelling Approaches

O-2018.06, P-2019.03, Q-2019.12

- Quasi-stationary Drift Diffusion
 - solve McIntyres differential equation for breakdown probability P_e
 - gives P_e , Dark Count Rate (DCR) and Photon Detection Efficiency (PDE)
 - no carrier dynamics, no minority carrier effects
- Transient Drift Diffusion
 - tweaked with PMI (no SRH generation, quantized avalanche [Webster et al, 2013])
 - reflects carrier dynamics
 - sweep through absorption locations

R-2020.09

- Full-band Monte Carlo (Garand MC)
 - full physics: dead space, accurate P_e , stochastic distributions
 - computationally more expensive. 2nd DD step required for DCR calculation

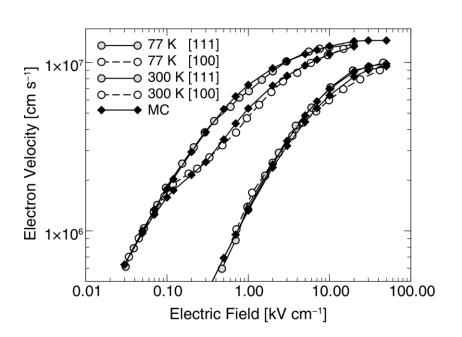
Garand MC – Physical Models

Band Structure

Efficient analytic or accurate full band models

Phonon Scattering

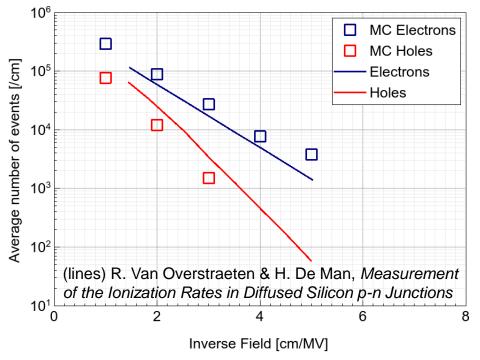
Well calibrated bulk Silicon transport



Impact Ionization

- Empirical rate calibrated for electrons & holes
- Development of enhanced model underway

Silicon Impact Ionization Coefficient



Detection Time Distribution – Jitter

multiplication region high field dead space

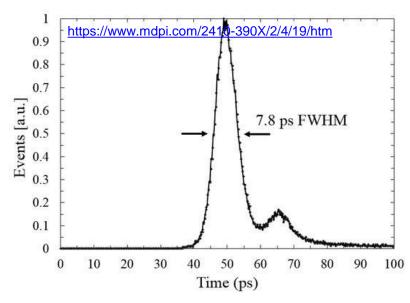
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Impact Ionization => random pair
creation (Monte Carlo transport)

also resolves dead space, within which carriers have insufficient energy for impact ionization

Photon absorption => random pair creation (S-Device optics)

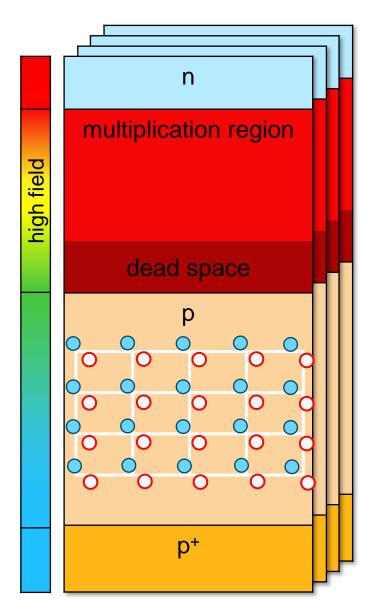
Phonon scattering => random walk (Monte Carlo transport)

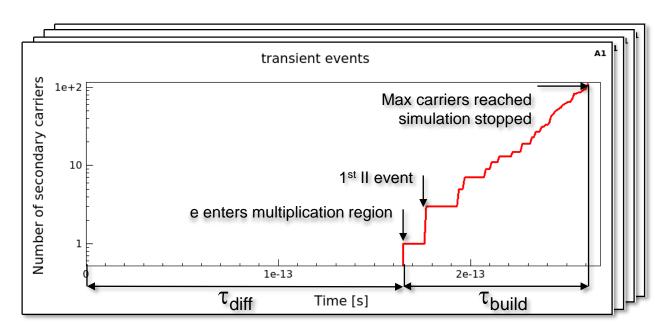


- Random processes result in jitter
- Important design parameter
- Limits system resolution
 - photon arrival time
 - LiDAR object resolution

ootential

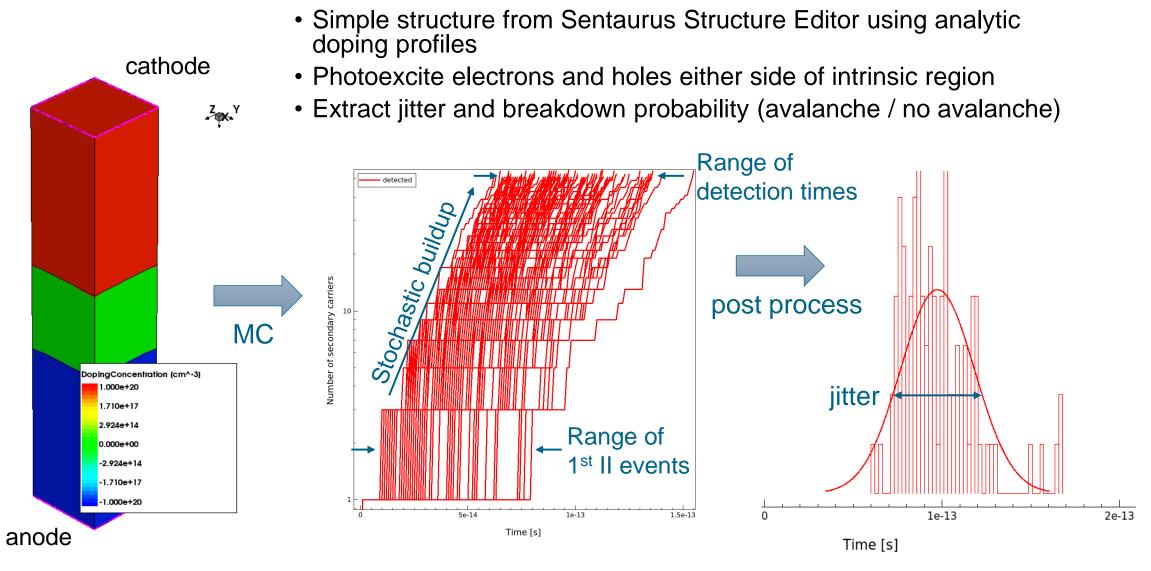
Garand MC – Execution Model





- Garand MC simulates carrier diffusion and impact ionization
- History of each photo excited carrier is output for processing
- Multiple histories may be simulated in a single MC instance
- Multiple instances may be run and all output aggregated
 - easily scalable, limited by resource & licences only
- More samples => more accuracy

Example— Carrier Histories and Jitter



Photodetector Simulation

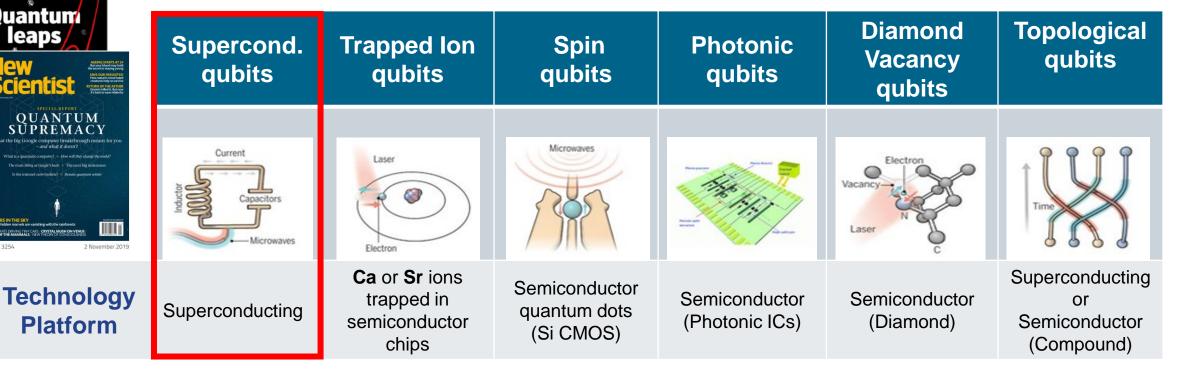
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Quantum Computing Promises to Revolutionize Key Industries: Drug Development, Finance, Cybersecurity ...

Platform

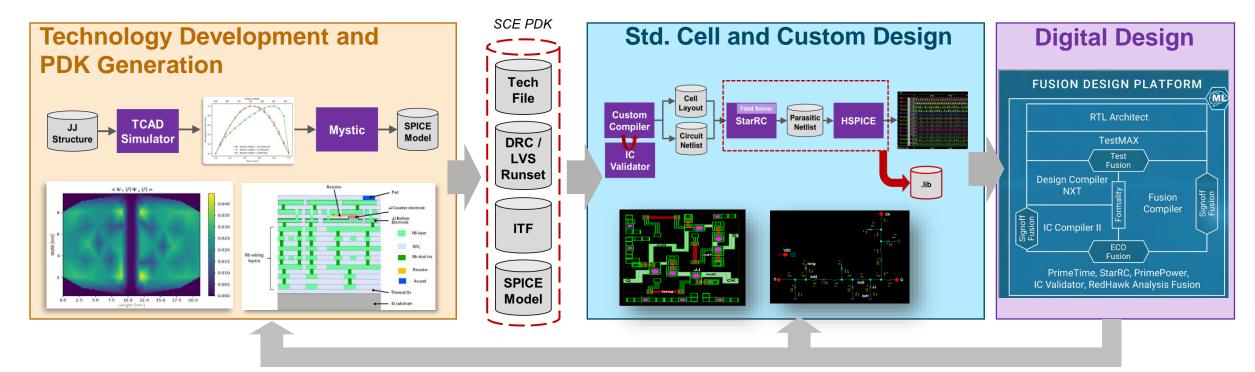
Several qubit types are in R&D for physical realization of quantum computers

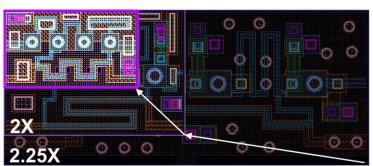


Near term Synopsys focus is to support development of superconducting qubit quantum hardware

- Natural extension from SuperTools development
- Superconducting qubits are engineered systems ("artificial atoms"), amenable to design

SCE EDA Flow Developed Under IARPA SuperTools Supports the Design of Large Scale SCE Circuits





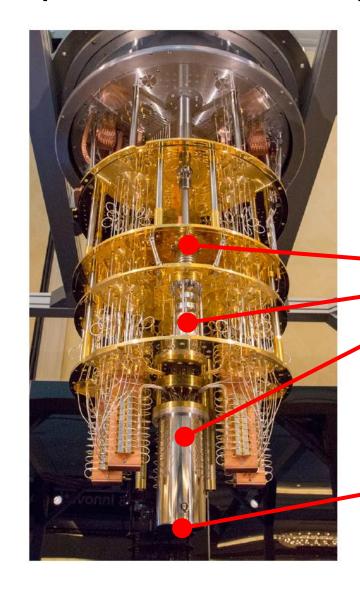
Source: S. Tolpygo, et al., MIT LL, EUCAS 2017

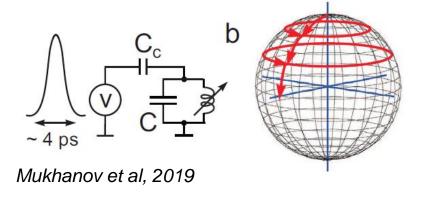
DTCO flow supports scaling of SCE technologies to achieve higher functionality

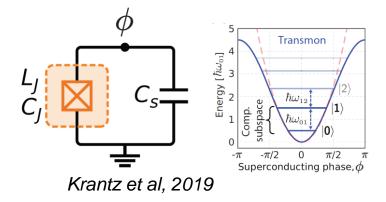


Provides foundation for new solutions to address Quantum Computing superconducting designs

Synopsys Focus: Extend SuperTools Flow to Support Optimization of Superconducting-Based Quantum Hardware



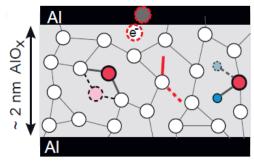




Design of superconducting and cryo-CMOS qubit control and read out interface circuits

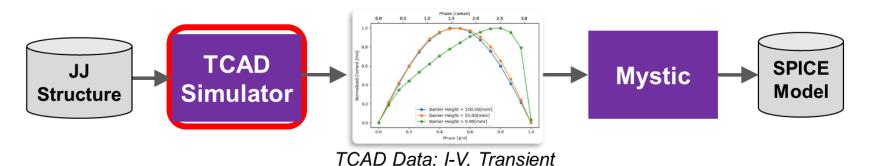
400 nm

Design, noise modeling and manufacturing optimization of superconducting qubits

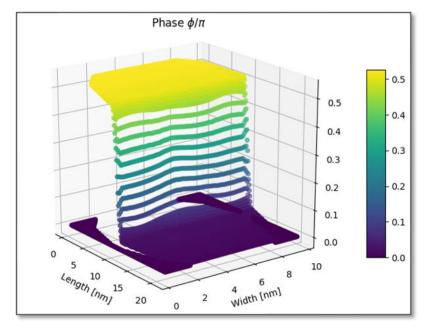


Muller et al, 2019

TCAD SCE Simulator Is Used to Model Josephson Junctions for Single Flux Quantum Circuits and Superconducting Qubits



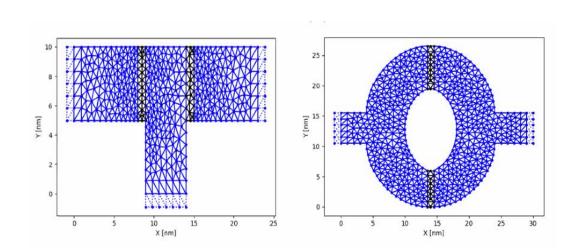
- Fully quantum mechanical simulator
- Inputs: device structure and material properties
- Outputs:
 - Current vs. phase relations
 - Current vs voltage characteristics
 - Cooper pair density profile, proximity effect
 - Temperature dependence



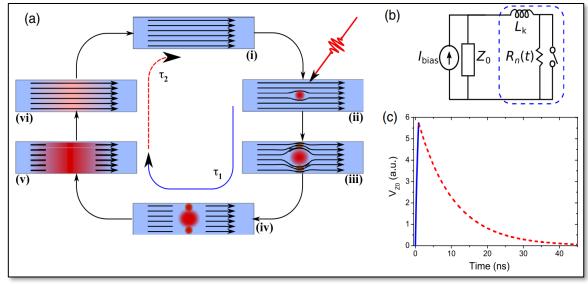
Spatial distribution of superconducting phase across JJ for $\phi_L = \frac{\pi}{2}$, $\phi_R = 0$

Beyond Simulation of JJs, TCAD SCE Simulator is Being Extended to Simulate Superconducting Nanowire Single Photon Detectors

- Employs FEM to solve quantum transport problem based on Bogoliubov-deGennes (BdG) Hamiltonian
- Arbitrary 1D / 2D / 3D structures
- Parallelized for efficient computation



- SNSPDs are critical devices for Quantum Communication and Optical Quantum Computers
- Performance optimization motivates design modeling and fabrication improvements

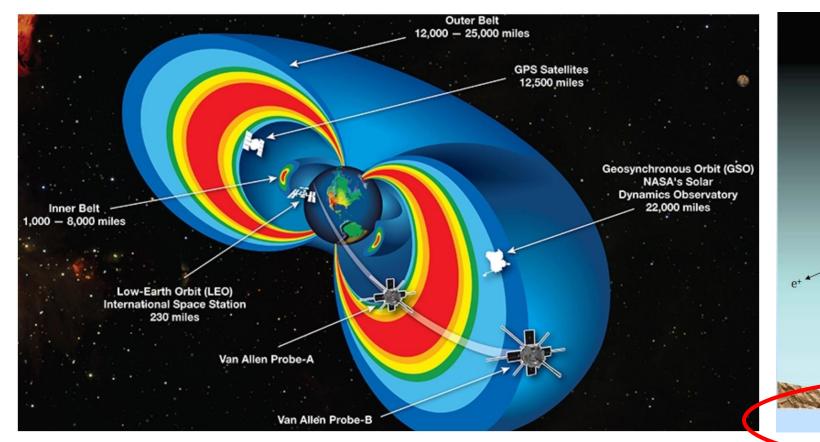


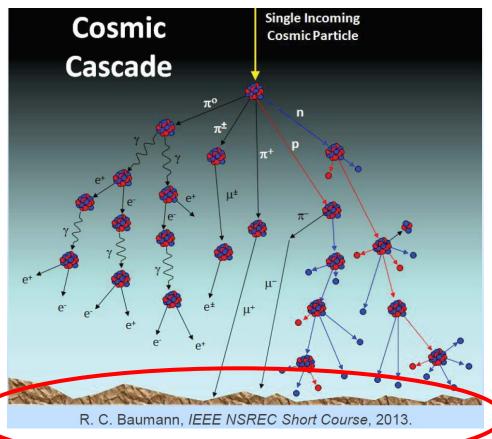
Natarajan et al, Supercond. Sci. Technol. 25 (2012) 063031

Particle Detection / Radiation Analysis



The Problem: Radiation Environment Around the Earth Is Critically Damaging to Electronics; Requires Radiation Hardening





Even on the Earth's surface, radiation impacts reliability of electronic systems

Radiation Effects Are Broadly Classified into Two Areas

Cumulative effects

Displacement damage

Total ionizing dose (TID)

Single event effects (SEE)

Non-destructive effects

Destructive effects

Single event transient (SET)

Single event upset (SEU)

Single even function interrupt

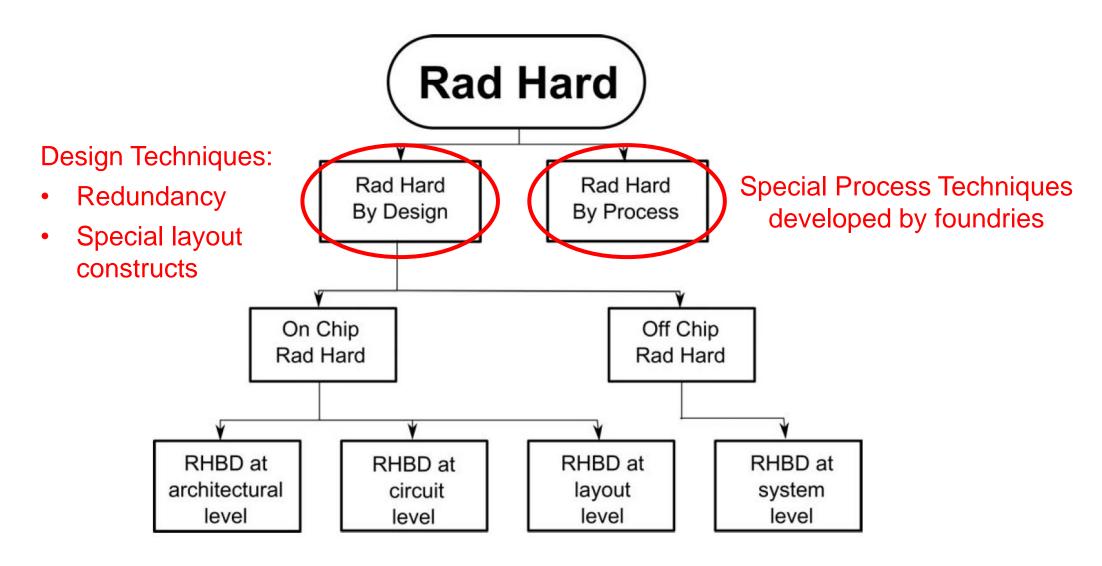
Single event latchup

Single event snapback

Single event burnout

Single event gate rupture

There are Two Main Techniques for Radiation Hardening



SYNOPSYS°

Heavy Ion Model

- Analytical generation model dependent on ion LET
- Customizable model through API: Physical Model Interface (PMI)

Electron-hole generation rate:
$$G(l, w, t) = T(t) \times R(w, l) \times G_{LET}(l)$$

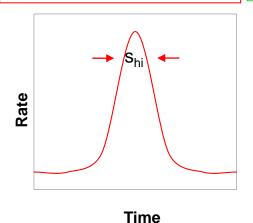
$$T(t) = \frac{2 \cdot \exp\left(-\left(\frac{t - time}{s_{hi}}\right)^{2}\right)}{s_{hi}\sqrt{\pi}\left(1 - erf\left(\frac{time}{s_{hi}}\right)\right)}$$

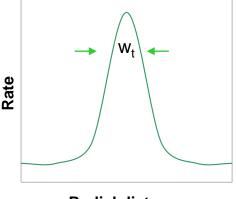
$$R(w,l) = \begin{cases} e^{-\left(\frac{w}{w_t(l)}\right)} \\ e^{-\left(\frac{w}{w_t(l)}\right)} \end{cases}$$

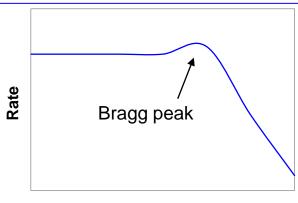
$$T(t) = \frac{2 \cdot \exp\left[-\left(\frac{t - time}{s_{hi}}\right)\right]}{s_{hi}\sqrt{\pi}\left[1 - erf\left(\frac{time}{s_{hi}}\right)\right]}$$

$$R(w,l) = \begin{cases} e^{-\left(\frac{w}{w_{l}(l)}\right)} \\ e^{-\left(\frac{w}{w_{l}(l)}\right)} \end{cases}$$

$$G_{LET}(l) = a_{1} + a_{2} \times l + a_{3}e^{a_{4} \times l} + k'\left[c_{1} \times (c_{2} + c_{3} \times l)^{c_{4}} + LET - f(l)\right]$$



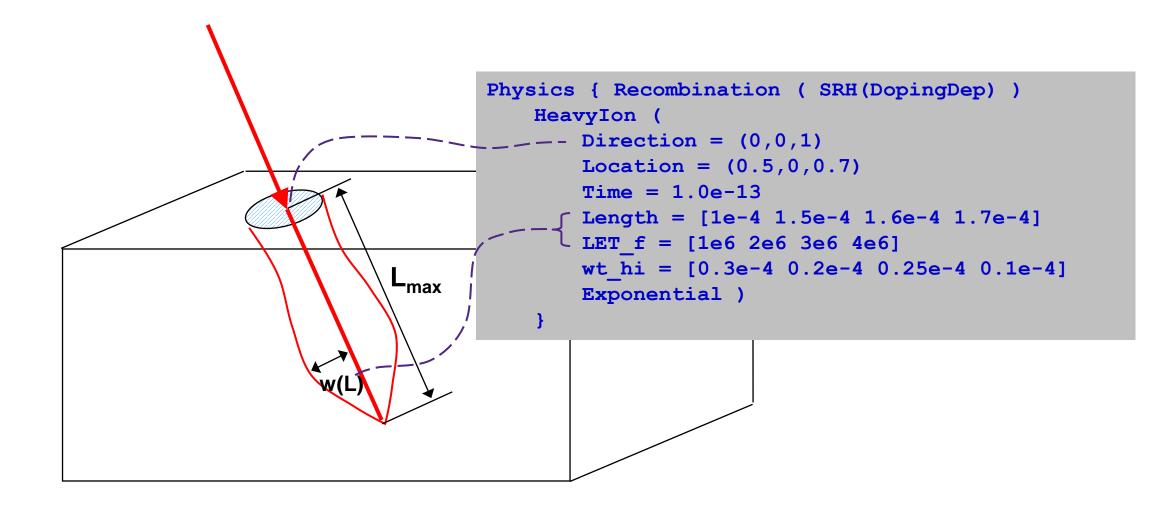




Radial distance

Distance along track

Simulation of Charge Track



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TID Simulation Approach

- The received radiation dose is transferred into a space charge, captured by traps located in dielectric
- Carrier generation by gamma radiation with electric field dependent yield function:

```
Physics {
   Radiation (
    DoseRate = @DoseRate@
    DoseTime = (50,500)
    DoseTSigma = 2
```

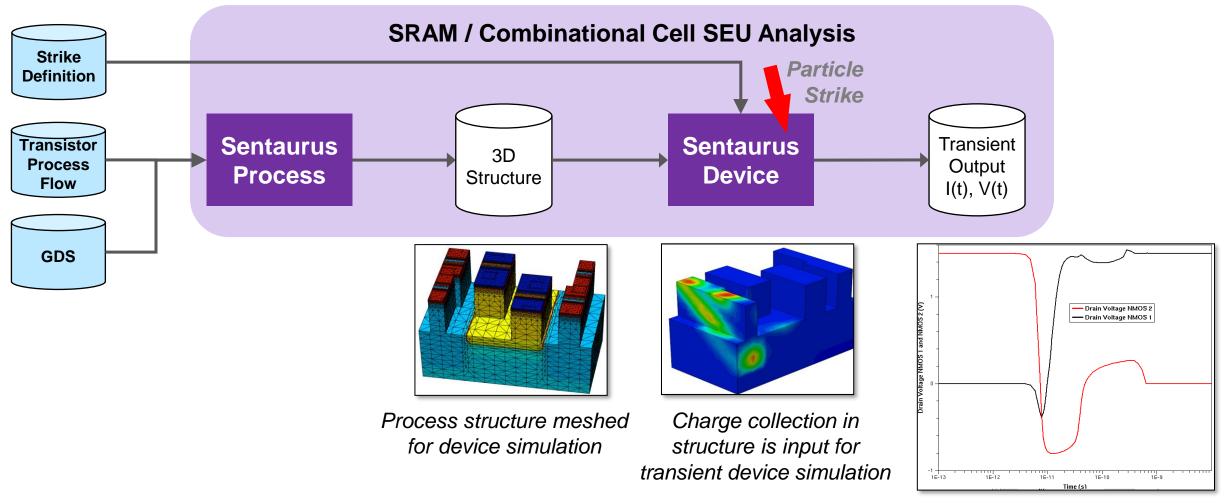
$$G_r = g_0 D \cdot Y(F)$$

$$Y(F) = \left(\frac{F + E_0}{F + E_1}\right)^m$$

• Oxides are defined as OxideAsSemiconductor where transport and local trap capture and emission equations are solved

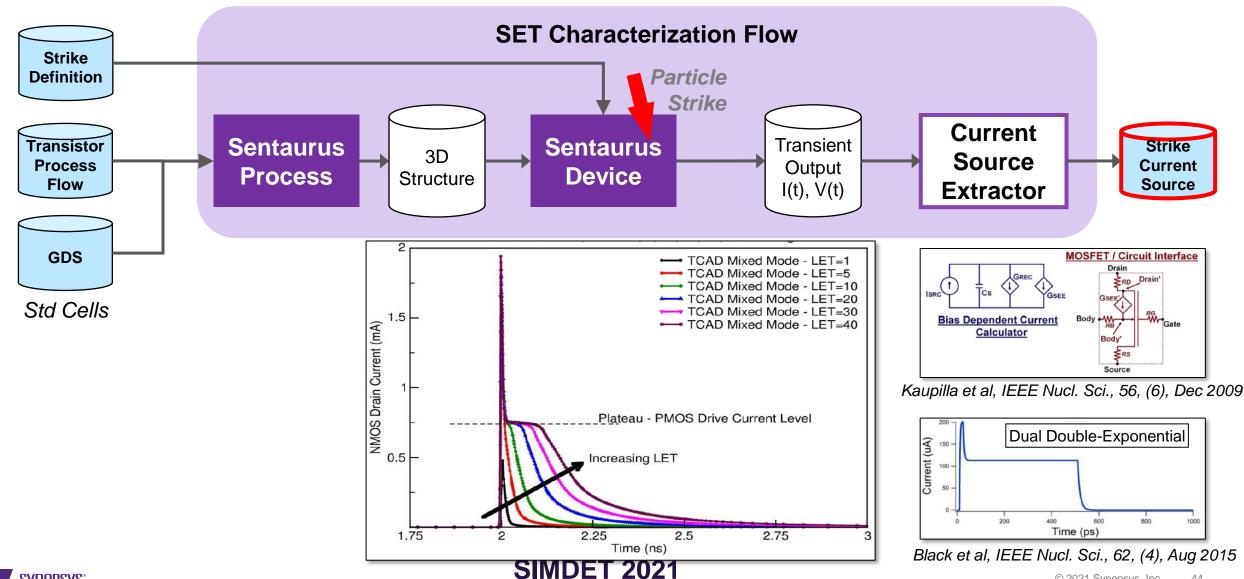
```
Physics (Material="OxideAsSemiconductor") {
    Traps (
    (Donor Conc=@Conc@ Level EnergyMid=@EMid@ FromMidBandGap
        eXsection = 1e-11 hXsection = @xSec@ )
```

SRAM / Combinational Cell Single Event Upset (SEU) Simulation Flow



Transient output indicates if bit is upset for specific strike definition

Single Event Transient (SET) Characterization Flow



Synopsys TCAD Has Extensive Capabilities to Support the Design of Semiconductor and Superconductor Detectors

- CMOS Image Sensors (CIS), with focus on 3D process optimization and co-design with amplifier circuits
- Single Photon Avalanche Photodiodes (SPAD)
- Development of TCAD simulator for superconducting electronics with application to Superconducting Nanowire Photo Detectors (SNSPD)
- TCAD-to-SPICE flows for radiation effects

Thank you for your attention

SYNOPSYS® Silicon to Software®

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Contact us at: tcad_team@synopsys.com